



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takeshi KIJIMA et al.

Group Art Unit: 2812

Application No.: 10/722,422

Examiner: S. GEYER

Filed: November 28, 2003

Docket No.: 117897

For: METHOD OF MANUFACTURING CERAMIC FILM, METHOD OF
MANUFACTURING FERROELECTRIC CAPACITOR, CERAMIC FILM,
FERROELECTRIC CAPACITOR, AND SEMICONDUCTOR DEVICE

AMENDMENT UNDER 37 C.F.R. §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Further to the February 2, 2006 Office Action, the period for reply being extended by
the attached Petition for Extension of Time, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.